



FORM PTO-1449	APPLICATION NO. 10/681,528	CASE NO. 10541-1808
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	FILING DATE October 8, 2003	ART UNIT 2874 2883
APPLICANT(S): Zhong-Your Joe Shi		

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
<i>Colt</i>	3,971,891	01/21/75	Hasegawa et al.		10/18/73
	4,422,719	12/27/83	Orcutt		05/07/81
	4,471,412	09/11/84	Mori		12/30/82
	4,747,658	05/31/88	Borsuk et al.		03/14/83
	4,759,600	07/26/88	Caron et al.		05/15/85
	5,027,259	06/25/91	Chujko		03/05/90
	5,050,956	09/24/91	Carpenter et al.		09/20/90
	5,222,795	06/29/93	Hed		12/26/91
	5,321,784	06/14/94	Cubukciyan et al.		02/18/93
	5,606,637	02/25/97	Dolby		07/21/95
	5,816,626	10/06/98	Anderson et al.		12/05/95
	5,901,267	05/04/99	Lee		05/15/97
	6,206,533	03/27/01	Shi		12/13/99
<i>CNC</i>	6,431,717	08/13/02	Anderson et al.		03/07/00

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES NO
<i>CNC</i>	JP 1-134406	1989.05.26	JAPAN		Abstract
<i>CNC</i>	JP 63-064007	1988.03.22	JAPAN		Abstract
<i>CNC</i>	JP 2-85808	1990.03.27	JAPAN		Abstract

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER <i>Chris Salvard</i>	DATE CONSIDERED 6-2-05
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.